

INTERNATIONAL STANDARD

NORME INTERNATIONALE

**Piezoelectric sensors –
Part 3: Physical sensors**

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**Capteurs piézoélectriques –
Partie 3: Capteurs physiques**

IEC 63041-3:2020

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IEC Central Office
3, rue de Varembe
CH-1211 Geneva 20
Switzerland

Tel.: +41 22 919 02 11
info@iec.ch
www.iec.ch

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PIEZOELECTRIC SENSORS –

Part 3: Physical sensors

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The text of this International Standard is based on the following documents:

CDV	Report on voting
49/1333/CDV	49/1343/RVC

Full information on the voting for the approval of this International Standard can be found in the report on voting indicated in the above table.

This document has been drafted in accordance with the ISO/IEC Directives, Part 2.

A list of all part in the IEC 63041 series, published under the general title *Piezoelectric sensors*, can be found on the IEC website.

The committee has decided that the contents of this document will remain unchanged until the stability date indicated on the IEC website under "<http://webstore.iec.ch>" in the data related to the specific document. At this date, the document will be

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PIEZOELECTRIC SENSORS –

Part 3: Physical sensors

1 Scope

This part of IEC 63041 is applicable to piezoelectric physical sensors mainly used in the field of process control, wireless monitoring, dynamics, thermodynamics, vacuum engineering, and environmental sciences. This document provides users with technical guidelines as well as basic knowledge of common physical sensors.

Piezoelectric sensors covered herein are those applied to the detection and measurement of physical quantities such as force, pressure, torque, viscosity, temperature, film thickness, acceleration, vibration, and tilt angle.

2 Normative references

The following documents are referred to in the text in such a way that some or all of their content constitutes requirements of this document. For dated references, only the edition cited applies. For undated references, the latest edition of the referenced document (including any amendments) applies.

IEC 60027 (all parts), *Letter symbols to be used in electrical technology*

IEC 60050-561, *International electrotechnical vocabulary – Part 561: Piezoelectric, dielectric and electrostatic devices and associated materials for frequency control, selection and detection*

IEC 60617:2012, *Graphical symbols for diagrams* (database available at <http://std.iec.ch/iec60617>)

IEC 63041-1:2017, *Piezoelectric sensors – Part 1: Generic specifications*

IEC 63041-2, *Piezoelectric sensors – Part 2: Chemical and biochemical sensors*

ISO 80000-1, *Quantities and units – Part 1: General*

3 Terms, definitions, symbols and units

3.1 Terms and definitions

For the purposes of this document, the terms and definitions given in IEC 60027 (all parts), IEC 60050-561, IEC 60617, IEC 63041-1, IEC 63041-2 and ISO 80000-1 and the following apply.

ISO and IEC maintain terminological databases for use in standardization at the following addresses:

- IEC Electropedia: available at <http://www.electropedia.org/>
- ISO Online browsing platform: available at <http://www.iso.org/obp>

3.1.1

piezoelectric acceleration sensor element

piezoelectric sensor component whose resonance frequency or delay is used to measure the change in velocity of an object with time

3.1.2

piezoelectric humidity sensor element

piezoelectric sensor component whose resonance frequency or delay is used for dew point and moisture detection

3.1.3

piezoelectric tilt angle sensor element

piezoelectric sensor component whose resonance frequency or delay is used to measure tilt angles, elevation, or depression of an object with respect to gravity's detection

3.1.4

piezoelectric vibration sensor element

piezoelectric sensor component whose resonance frequency or delay is used for measurement of vibration

3.1.5

dual mode sensor

piezoelectric sensor which is able to detect physical quantities from a change in resonance frequencies of two independent modes on a single piezoelectric plate

Note 1 to entry: In order to achieve improved precision and/or to eliminate undesired influence factors, sensor solutions are employed that utilize two or more modes. By evaluation of combinations of these modes' sensitivities to various ambient conditions, on the one hand, improved detection sensitivity can be achieved, while, on the other hand, undesirable sensitivities can be reduced or eliminated.

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3.1.6

differential sensor

piezoelectric sensor which is able to detect physical quantities from a change in resonance frequencies or delays of two independent and same micro-acoustic structures assembled on the same or different piezoelectric plates

3.1.7

multi-measurand sensor

piezoelectric sensor which is able to detect two or more different physical quantities from an analysis of different sensor responses

3.2 Symbols and units

The symbols and units given in IEC 63041-1 apply.

4 Specifications

4.1 General

Key points of the specification are identified in IEC 63041-1:2017, Clause 5.

4.2 Conceptual diagrams of sensor types

4.2.1 General

In addition to the sensor types listed in IEC 63041-1:2017, Clause 4, specific realizations are common for surface acoustic wave (SAW) sensors.

4.2.2 Conceptual diagram for sensor elements of SAW resonator type

Figure 1 and Figure 2 show conceptual diagrams for resonator type SAW sensors. Figure 1 provides one resonance which is sensitive to undesirable influence factors such as frequency pulling. In the case of Figure 2, comprising e.g. a parallel connection of two resonators at different resonance frequencies, the sensor will be designed to have similar sensitivities of both resonators to such undesired effects and is therefore suitable to achieve higher accuracy with respect to the target measurand due to this compensation technique.

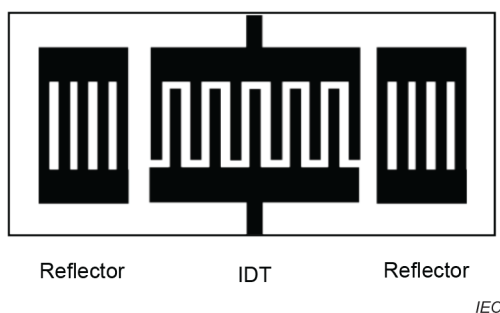


Figure 1 – Conceptual diagram for SAW single resonator type



Figure 2 – Conceptual diagram for SAW differential resonator type

4.2.3 Conceptual diagram for sensor elements of SAW delay-line type

Figure 3 shows a transmission type (two-port) and Figure 4 shows a reflective type (one-port).

Reflective delay lines use the SAW propagation path which is evaluated for delay and attenuation changes twice for incident and reflected wave, and therefore can be designed as smaller realizations. Reflective delay-line sensors can be designed to feature a unique sensor identification, in combination with their sensor capabilities, by using several SAW reflector structures resulting in a characteristic pattern of the reflected signal which can be distinguished from other sensors using the same frequency range.

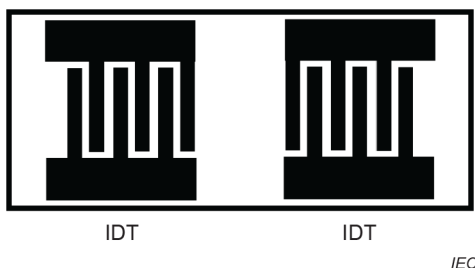


Figure 3 – Conceptual diagram for SAW transmission (two-port) delay-line type

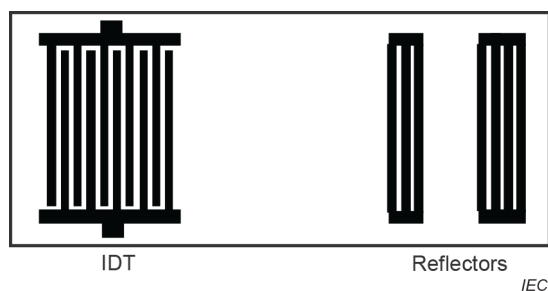


Figure 4 – Conceptual diagram for SAW reflective (one-port) delay-line type

4.3 Technical documents

The physical reaction in sensor cell and detection methods are defined in Annex A.

The following a) to f) shall clearly be defined in the specifications to be concluded between the manufacturer and customers:

- a) Avoidance of coupling of main and unwanted vibration modes;
- b) Detection direction of sensor element;
- c) Hysteresis of sensor elements;
- d) Linearity between sensor outputs and physical quantities to be detected;
- e) Overload characteristics by excessive physical quantities to be detected;
- f) Response time of sensor elements.

5 Delivery conditions

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See IEC 63041-1:2017, Clause 7. [cd706a906501/iec-63041-3-2020](https://standards.iteh.ai/catalog/standards/sist/39dfl d5c-0ff9-41fe-acf7-cd706a906501/iec-63041-3-2020)

6 Quality and reliability

See IEC 63041-1:2017, Clause 8.

7 Test and measurement procedures

See IEC 63041-1:2017, Annexes A and B.

Annex A (informative)

Physical reaction in sensor cell and detection method

A.1 Detection and measurement

Generally, detection and measurement items are a) to d).

- a) Resonance frequency, delay, and electrical charged voltage covered herein are applied to the detection and measurement of force, pressure, torque, vibration, acceleration, etc.
- b) Resonance frequency, delay or insertion loss / gain covered herein are applied to the detection and measurement of viscosity.
- c) Resonance frequency or delay is applied to the detection and measurement of temperature.
- d) Resonance frequency is applied to the detection and measurement of film thickness.

NOTE An electrical charged voltage is measured by non-acoustic type piezoelectric ceramic and quartz crystal sensors.

For these specifications, the manufacturer and customer shall have detailed discussions, the discrepancies shall be eliminated, and the results shall clearly be described in the contract clause, the requirements specifications of the customer, the delivery specifications thereof or the like, and shall be settled as one of the contracts with the customer.

A.2 Typical formulae for detection methods of physical quantity

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A.2.1 General

Formulae (A.1) to (A.6) presented as below are typical examples applied to physical sensor elements and cells. For these formulae, the manufacturer and customer shall have detailed discussions, the discrepancies shall be eliminated, and the results shall be described clearly in the contract clause.

A.2.2 Non-acoustic type

A.2.2.1 Piezoelectric ceramics

When a sensor element is made of piezoelectric ceramics,

$$V = g_{33} l \frac{F}{S} \quad (\text{A.1})$$

where

- V is the voltage;
- g_{33} is the piezoelectric voltage coefficient;
- l is the length of the piezoelectric ceramics element and is the direction in which force is applied to the one;
- F is the force applied to the piezoelectric ceramic element and cell;
- S is the electrode area and is formed in a direction in which a force is applied to the piezoelectric ceramic element and cell.

A.2.2.2 X-cut quartz crystal

When sensor element is X-cut quartz crystal,

$$V = g_{11} t \frac{F}{S} \quad (\text{A.2})$$

where

g_{11} is the piezoelectric voltage coefficient;

t is the thickness of quartz crystal.

A.2.3 Acoustic type

A.2.3.1 Resonator type

For resonator-type piezoelectric sensors, the change of one or more resonance frequencies related to the effect of the measurand is interpreted to quantify the measurand. Typical measuring range transform function is defined by polynomials as

$$y = g(\Delta f_r) = \sum_{i=0}^N a_i f_r^i \quad (\text{A.3})$$

where

y is the measurand (e.g. temperature, pressure, film thickness, etc.);

Δf_r is the change of resonance frequency under the influence of the measurand;

a_i are transform coefficients, determined by design and material system.

Biunique the transform function is generally desirable. Hence, the order of the polynomial should be kept low, ideally $N = 1$.

A.2.3.2 Differential resonator type

For differential resonator type sensors, it is common to evaluate two resonances with different sensitivities to the measurand in order to eliminate undesired frequency pulling effects (e.g. from load pulling effects in wireless piezoelectric sensor systems), such as

$$y = g(\Delta f_{r1} - \Delta f_{r2}) = \sum_{i=0}^N b_i (\Delta f_{r1} - \Delta f_{r2})^i \quad (\text{A.4})$$

where

$\Delta f_{r1}, \Delta f_{r2}$ are resonance frequencies of two resonators or resonant modes with different sensitivities with respect to the measurand, but preferably similar sensitivities with respect to undesired influence actors;

b_i are transform coefficients, determined by design and material system.

A.2.3.3 Multi-measurand resonator type

Evaluation of two or more resonators and their resonance frequencies, having arbitrary sensitivities with respect to the measurands to be quantified, can be transformed by